Series V41

REMOTE PLASMA CLEANING VALVE

PRESYS
PREMIUM SYSTEM



Application

_High vacuum process
_All CVD process(including MO, PE, HDP, LP and AP)
_Photovoltaic and semiconductor application

Features

_Pneumatic actuation
_Rated for 1million cycles
_Double o-ring seal
_Easy maintenance

Options

_Custom sizes available
_Various o-ring compounds (Kalrez®, Chemraz®, etc.)

www.presys.kr

PREMIUM SYSTEM PRESYS

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